RMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor	Chilimbi	
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Examiner Name	Not yet assigned	

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee		
MPF		6,360,361	3/19/2002	Larus et al.		
MPF		6,330,556	12/11/2001	Chilimbi et al.		
MPF		6,321,240	11/20/2001	Chilimbi et al.		
MPF		5,940,618	8/17/1999	Urquhart et al. BLANDY ET AL.		
MPF		2005/0091645	4/28/2005	Chilimbi et al.		
MPF		2004/0103408	5/27/2004	Chilimbi et al.		
MPF		2004/0103401	5/27/2004	Chilimbi et al.		
MPF		2004/0025145	2/5/2004	Dawson		
MPF		2002/0144245	10/3/2002	Lueh		
MPF		11/134,812	5/20/2005	Ganapathy et al.		
MPF	:	11/134,796	5/20/2005	Shankar et al.		
MPF		11/115,924	4/26/2005	Chilimbi et al.		
Examiner's Initials*	Cite No. (optional)	OTHER DOCUMENTS				
MPF		Ammons et al., "Exploiting Hardware Performance Counters with Flow and Context Sensitive Profiling", PLDI (June 1997), 12 pages.				
MPF		Ammons et al., "Improving Data-Flow Analysis with Path Profiles," SIGPLAN '98 (1998), pages 72-84.				
MPF		Anderson et al., "Continuous Profiling: Where Have All the Cycles Gone?", ACM (November 1997), pages 357-390.				
EXAMINER M. D. DATE CONSTREPED 2/16/6-7						

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^{*} Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.